P27153.A06 Application No.: 10/605,906

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): An L. STEEGEN et al.

Confirmation No. 2905

Appln. No. : 10/605,906

Group Art Unit: 2813

Filed

: November 5, 2003

Examiner: Stephen W. Smoot

For

: METHOD AND STRUCTURE FOR FORMING STRAINED SI FOR

CMOS DEVICES

Commissioner for Patents U.S. Patent and Trademark Office Customer Service Window, Mail Stop Amendment Randolph Building 401 Dulany Street Alexandria, VA 22314

AMENDMENT UNDER 37 C.F.R. §1.112

Sir:

In response to the Office Action dated March 31, 2006, please amend the aboveidentified application as follows.

A listing of claims is set forth on pages 2-5.

Remarks begin on page 6.

If extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. §1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to Deposit Account No. 09-0458.